Substitute for form 1449A/B/PTO	**Complete If Known**	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT *(Use as many sheets as necessary)*	Application Number	~~Not Yet Assigned~~ 10/660,977
	Filing Date	Concurrently Herewith
	First Named Inventor	Richard A. Haight
	Art Unit	N/A
	Examiner Name	Not Yet Assigned

Sheet	1	of	1	Attorney Docket Number	20140-00303-US1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Document Number — Number-Kind Code[2] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
GSE	AA	US-6333485	12/25/01	Haight et al.	
GSE	AB	US-6190836	2/20/01	Grenon et al.	
GSE	AC	US-6165649	12/26/00	Grenon et al.	
GSE	AD	US-6156461	12/05/00	Grenon et al.	
GSE	AE	US-6050907	04/18/00	Long	
GSE	AF	US-5656186	08/12/97	Mourou et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Foreign Patent Document — Country Code[3]-Number[4]-Kind Code[5] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. [1] Applicant's unique citation designation number (optional). [2] See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. [3] Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). [4] For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. [5] Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. [6] Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
GSE	CA	MARS2: An Advanced Femtosecond Laser Mask Repair Tool, A. Wagner, R. Haight, P. Longo, SPIE, 42, 457 (2002)	
GSE	CB	Femtosecond Laser Mask Repair, A. Wagner, R. Haight, P. Longo, M. Schmidt, P. Flanigan, D. Thibault, Microlithog. World, 12, 6, 2003	
GSE	CC	Femtosecond Lasers Repair Photomasks, R. Haight, P. Longo, A. Wagner, Laser Focus World, May 2002	
GSE	CD	MARS: A Femtosecond Laser Mask Advanced Repair System in Manufacturing, R. Haight, D. Hayden, P. Longo, T. Neary, A. Wagner, J. Vac. Sci.Technol., B 17, 3137 (1999).	
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[1] Applicant's unique citation designation number (optional). [2] Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	Geoffry A Evan	Date Considered	October 3, 2005